

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor(s) : Franz LAERMER  
 Serial No. : 10/519,724  
 Filed : December 28, 2004  
 For : DEVICE AND METHOD FOR THE PRODUCTION OF  
       CHLORINE TRIFLUORIDE AND SYSTEM FOR  
       ETCHING SEMICONDUCTOR SUBSTRATES USING  
       THIS DEVICE  
 Examiner : Rakesh Dhingra  
 Art Unit : 1792  
 Confirmation No. : 5180

Mail Stop Amendment  
 Commissioner for Patents  
 P.O. Box 1450  
 Alexandria, Virginia 22313-1450

I hereby certify that this correspondence is being  
 electronically transmitted to the United States Patent and  
 Trademark Office via the Office electronic filing system  
 on August 10, 2009.

Signature: Elizabeth Tretter/  
 Elizabeth Tretter

AMENDMENT TRANSMITTAL

SIR:

Transmitted herewith for filing in the above-identified patent application is an Amendment in response to the Office Action of February 10, 2009. Applicant respectfully petitions for **three-month extension of time** to respond to the Office Action of February 10, 2009, for which a three-month response period expired on May 10, 2009. The extended period for response expires on August 10, 2009.

The **\$1,110.00 three-month extension fee** and the **additional claim fee of \$220.00** (for the one (1) net added independent claim) are being paid by credit card.

The Commissioner is hereby authorized to charge **Kenyon & Kenyon LLP**, Deposit Account No. **11-0600** for any additional fee(s) and/or underpayments of fee(s) under 37 C.F.R. 1.16 and 1.17, or to credit any overpayments.

Respectfully submitted,

Date: August 10, 2009

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